

High Performance Computing (HPC)-Accelerated Inverse Deflectometry for Mirror Segment Metrology

> Presentation to NASA Mirror Tech / SBIR / STTR Workshop 2015

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NASA GSFC Technical Representative

Dr. Raymond G. Ohl

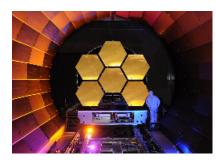


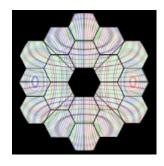


Introducing: *inverse* deflectometry + HPC = M-TEC™

- Instead of using *deflectometry* to determine the optical prescription (shape) of a telescope mirror
- We have been developing *inverse* deflectometry
- We start by assuming we already know the actual optical prescription and low-order figure error of the telescope mirror
 - Then use inverse deflectometry to determine 6 DOF misalignment of mirror segments in the telescope
 - And accelerate the process with *high performance computing* (HPC) to rapidly determine misaligned 6 DOF condition
- Our name for this new metrology technology is *M*-TEC[™]







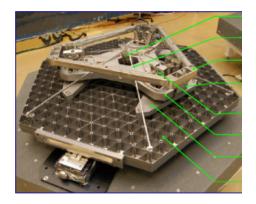




M-TEC[™] Permits Direct (Front-Viewing) Determination of Segment Alignment

- Allows front-viewing, *in situ* alignment-testing of mirror segments or other aspheres
- Versus metrology-references integral to the back or sides of each mirror segment

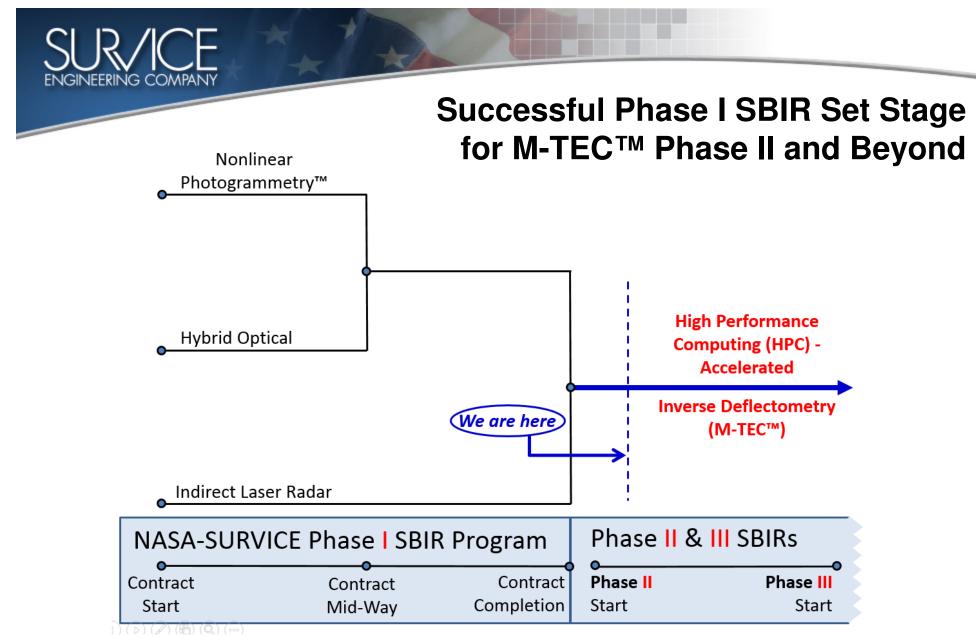




• Note: Images shown here are examples only and do not indicate the baseline alignment technique used for the JWST mirror segments













Overall Phase II / III Goals

- Develop and validate M-TEC[™] technology to accurately measure the global position and orientation of mirror segments or other aspheres for large telescopes
 - As-installed mirror configuration
 - Non-contact
 - At safe distance (greater than one meter)
- Transition and commercialize technology for NASA via collaboration with major OEM contractors
 - Projects like the James Webb Space Telescope
 - Other multi-segmented telescopes and optics



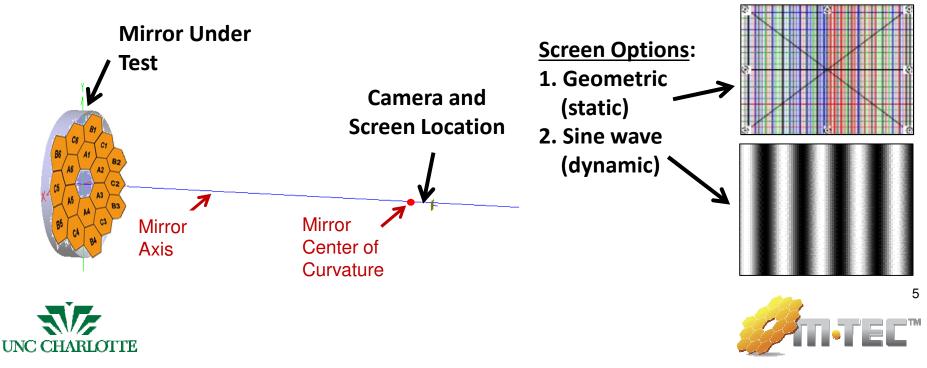




Inverse Deflectometry = New Twist on Prior Art

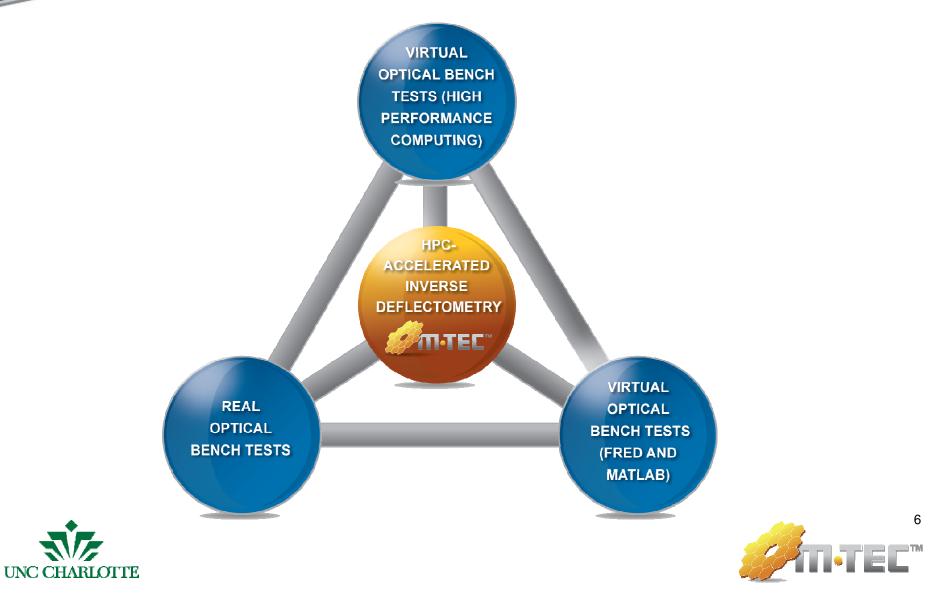
(Phase Measuring Inverse Deflectometry, or PMID)

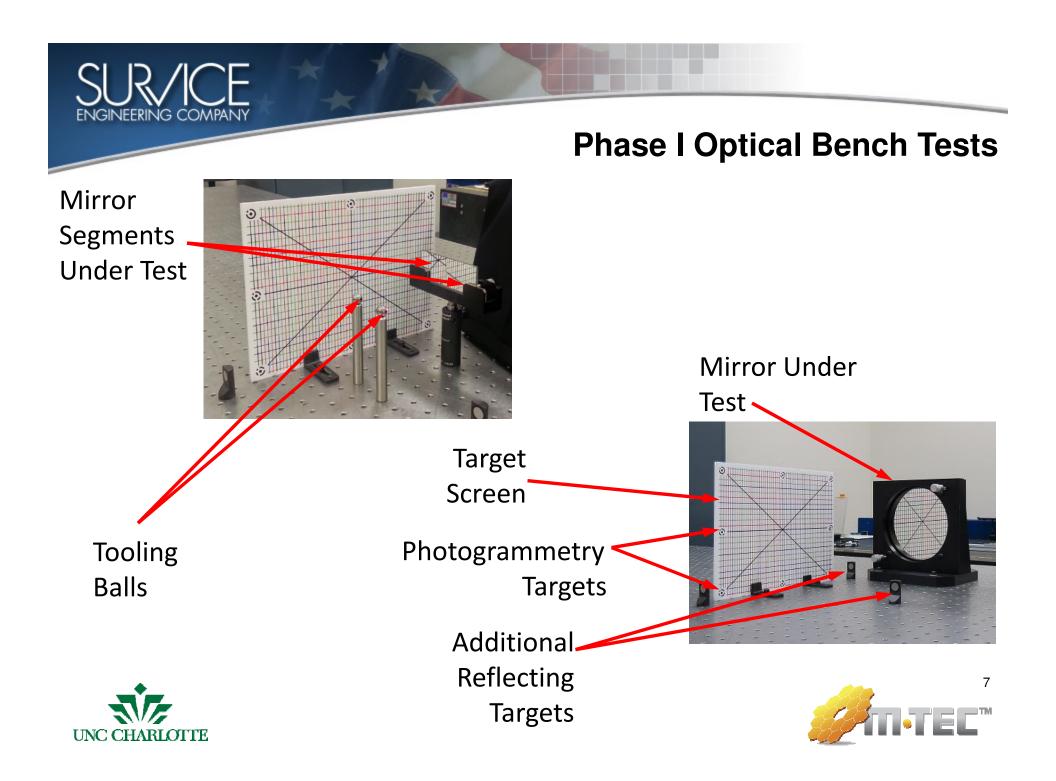
- Leverages prior work in deflectometry; for example
 - PMD (Phase Measuring Deflectometry) work by Knauer *et al.*, SPIE Proc. 5457, 366 -376 (2004)
 - SCOTS (Software Configurable Optical Test System) work by Su *et al.*, Appl. Opt. 49, 4404 – 4412 (2010)





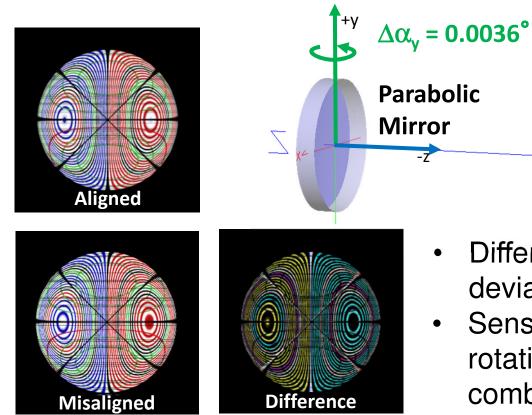
M-TEC[™] Development & Validation Process



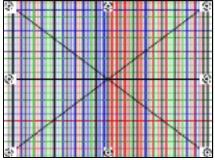




Sample Phase I Misalignment Analysis



Screen Pattern



- Difference plots reveal small deviations in mirror alignment
- Sensitivity simulations include rotations, translations, and combinations

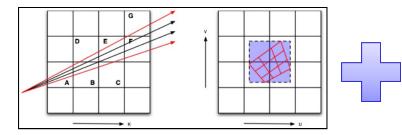




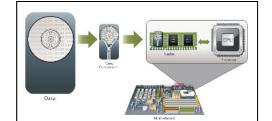


Application of High Performance Computing (HPC) to Inverse Deflectometry

- Compare actual digital image from optical test of mirror to physics-based simulated images computed via HPC
- Iteratively solve for mirror segment position



Best known methods in real-time ray tracing



Low-level, architecturespecific optimization

UIFIEL

HPC-Accelerated Inverse Deflectometry





SUR/ICE ENGINEERING COMPANY

SURVICE Engineering Company

www.survice.com

- Nationwide 350+ employees
 - Specialty engineering consulting & design
 - Serving US DoD for over 30 years
- Recognized expert in visualization and high performance computing (HPC)
 - Only small business with NVIDIA CUDA Research Center accreditation
- Recognized leader in metrology and reverse engineering services (metrology.survice.com)
- Dozens of highly competitive Small Business Innovation Research (SBIR) and other awards





SmartCEO Magazine Voltage Award for Technology Innovation



SURVICE leverages massively parallel computing architectures from NVIDIA and Intel









Previous SURVICE Metrology Support to NASA

- James Webb Space Telescope
 - NASA POC: Dr. Ray Ohl
 - Verification inspection with Nikon Coherent Laser Radar (CLR) for metrology inspection
- Magnetospheric Multiscale (MMS) Stack
 - NASA POC: Henry Sampler
 - Vantage POC: John Carro
 - Surphaser scanner verifies alignment and fit metrology regarding Atlas rocket payload section













SURVICE Engineering CR&D HPC and Metrology Devices & Tech



M-TEC™

NASA SBIR to develop HPC metrology tech, like James Webb Space Telescope



Hoverbike

DSIAC task with US Army & Malloy Aeronautics Ltd.



New RF propagation model built for Intel to showcase Xeon Phi



Enhanced-CLR™

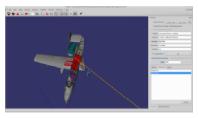
Completed MRL-7 demo on **F-35** production line in Palmdale CA.



HOLOS™

Working with Intelligent Earth Ltd. on low-cost touchprobe metrology tech





VSL (Visual Sim Lab)

High performance V/L analyses to be part of next AJEM release.

Apollo™

CFD running NVIDIA's CUDA on GPU

P&W (Pratt & Whitney) FAST //

Custom H/W & S/W solution for **F-22** engine exhaust duct data collection







Subcontractor: UNC Charlotte Center for Precision Metrology (CPM)

- <u>Research</u>: Development and integration of precision metrology as applied to manufacturing
- Facilities:
 - 4,000 sq. ft. of controlled environment for metrology and instrument development
 - 1,500 sq. ft. controlled environment, 20± 0.1° C, class 10,000 metrology laboratory
 - 33,000 sq. ft. laboratories & offices Duke Centennial Hall
- Extensive capabilities
 - Metrology
 - Precision manufacturing
- <u>CPM Affiliates</u>: B&W Y-12, Zeiss, Caterpillar, Corning Cable, Cummins, GE Energy, General Dynamics, Intel, LLNL, Micro Encoder, NIST, Renishaw, United Technologies











We are looking for partners (under an NDA)

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